

Search Notes

Application/Control No.

09/714,267

Examiner

Chuck Kendall

Applicant(s)/Patent under
Reexamination

MIMURA, TAKAYUKI

Art Unit

2192

SEARCHED

| Class | Subclass | Date | Examiner |
|-------|----------|-----------|----------|
| 717 | 124-135 | 6/21/2005 | CK |
| 714 | 38 | 6/21/2005 | CK |
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INTERFERENCE SEARCHED

| Class | Subclass | Date | Examiner |
|-------|----------|-----------|----------|
| 717 | 127-129 | 6/21/2005 | CK |
| 717 | 131 | 6/21/2005 | CK |
| 714 | 38 | 6/21/2005 | CK |
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**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

| | DATE | EXMR |
|---|-----------|------|
| East Search(USPAT,USPGPUB,IBM,DER WENT,JPO,EPO) | 6/21/2005 | CK |
| Google | 06/21/05 | CK |
| ACM | 6/21/2005 | CK |
| Consulted Wei XP 2192, Concurred with Allowable subject matter | 6/21/2005 | CK |
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